

Electronic Patent Application Fee Transmittal

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| Application Number: | 10772740 |
| Filing Date: | 05-Feb-2004 |
| Title of Invention: | METHOD OF PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION OF DIAMOND USING METHANOL-BASED SOLUTIONS |
| First Named Inventor/Applicant Name: | Yonhua Tzeng |
| Filer: | Jonathan O Owens |
| Attorney Docket Number: | 220101-1011 |

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| Miscellaneous-Filing: | | | | |
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| Patent-Appeals-and-Interference: | | | | |
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